

AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Tingkai Li, Sheng Teng Hsu, and Bruce D. Ulrich			Docket No. SLA0793		
Serial No 10/677,007	Filing Date September 30, 2003	Examiner Brian K. Talbot	Group Art Unit 1762		
Invention: MOCVD Selective Deposition of C-axis Oriented Pb3 Ge3 O11 Thin Films on In2 O3 Oxides					
TO THE COMMISSIONER FOR PATENTS:					RECEIVED CENTRAL FAX CENTER AUG 31 2005
Transmitted herewith is an amendment in the above identified application.					
The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER OF EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	20 -	16 =	4	x \$50.00	\$200.00
INDEP. CLAIMS	3 -	3 =	0	x \$200.00	\$0.00
Multiple Dependent Claims (check if applicable) _____					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$200.00

_____ No additional fee is required for amendment.

☒ Please charge Deposit Account No. 19-1457 in the amount of \$200.00.

A duplicate copy of this sheet is enclosed.

_____ A check in the amount of _____ to cover the filing fee is enclosed.

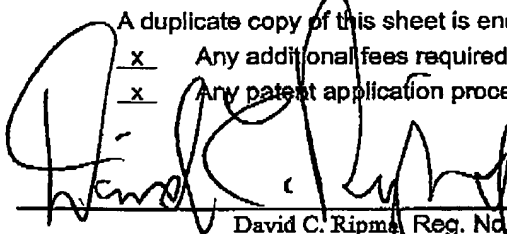
☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-1457.

A duplicate copy of this sheet is enclosed.

☒ Any additional fees required under 37 C.F.R. 1.16.

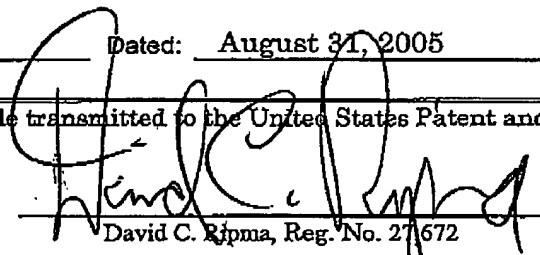
☒ Any patent application processing fees under 37 C.F.R. 1.17.

RECEIVED
OIPE/IAP
SEP 01 2005

 Dated: August 31, 2005

David C. Ripma, Reg. No. 27,672

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office under 37 C.F.R. §1.8 at Fax No. (703) 872-9306 on August 31, 2005.

 David C. Ripma, Reg. No. 27,672

Note: Each paper must have its own certificate of transmission, or this certificate must identify each submitted paper. The papers submitted include:

<input checked="" type="checkbox"/> This Amendment Transmittal Letter (Include Duplicate)	2 page(s)
<input checked="" type="checkbox"/> Response under 37 CFR § 1.111	17 page(s)
_____ Attachments	0 page(s)
_____	pages

Total pages, including this Transmittal: 19

RECEIVED
CENTRAL FAX CENTER

AUG 31 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/677,007
Applicant: Tingkai Li *et al.*
Filed: September 30, 2003
Group #: 1762
Examiner: Brian K. Talbot

Confirmation Number: 7277

Docket No: SLA.0793
Customer No: 27518
For: MOCVD Selective Deposition of C-axis Oriented $\text{Pb}_3\text{Ge}_3\text{O}_{11}$ Thin Films on In_2O_3 Oxides

MS AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

RESPONSE TO OFFICE ACTION UNDER 37 C.F.R. § 1.111
Introductory Comments

In response to the Office Action dated May 31, 2005, please amend the above-identified Application as follows:

Amendment to the Specification begins on page 2 of this paper.

Amendment to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Amendment to the Drawings None

Remarks/Arguments begin on page 12 of this paper.

An Appendix is not included.

09/01/2005 FHETEKI1 00000036 191457 10677007

01 FC:1202 200.00 DA